PTO/SB/08A (08-03)

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Substitute for form 1449/PTO

Sheet 1

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known				
Application Number	10/783,772			
Filing Date	2/20/2004			
First Named Inventor	CHOU			
Art Unit				
Examiner Name				
Attomey Docket Number	WMI002			

Examiner nitials*		Document Number	Publication Date	Name of Patentee or	·	Dagge Columns Lines 140
	Cite No.1		MM-DD-YYYY	Applicant of Cited Docum	ent	Pages, Columns, Lines, Where Relevant Passages or Relevant
		Number-Kind Code <sup>2 (I known)</sup>				Figures Appear
Su	1-	<sup>US-</sup> 6,046,659	<del>- 04-04-2000 -</del>	LOO, et al.	Di	DUCKER
7	2.	US-6,331,257	12-18-2001	LOO, et al.	<u> </u>	UPHCATO
	3	<sup>US-</sup> 6,842,097	01-11-2005	HSU, et al.	<del>- ()</del>	PHACKING
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	6	<sup>US-</sup> 5,121,089	06-09-1992	LARSON	<del></del>	
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 	FOREIGN	PATENT DOCU	MENTS		
Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	T
 	Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>8</sup> (if known)	MM-DD-YYYY		Or Relevant Figures Appear	₽
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Substitute for form 1449/PTO				Complete if Known		
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INF	ORMATION	DIS	CLOSURE	Filing Date	2/20/2004	
STA	STATEMENT BY APPLICANT			First Named Inventor	снои	
(Use as many sheets as necessary)				Art Unit		
	tose as many sne	ets as r	ecessary)	Examiner Name		
Sheet	2	of	2	Attorney Docket Number	WMI002	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Ţ²
Su	1	Petersen, K.E. 1978, "Dynamic micromechanics on silison: techniques and devices."	
	2	Petersen, K.E, "Forming the Contact Surface of Micromechanical Switches", IBM J. Res. Develop., vol.23, No.4, Jul. 1979, pp.376-385	
	3	Daniel Hyman, Juan Lam, Brett Warneke, Adele Schmitz, T. Y. Hsu, Julia Brown, James Schaffner, Andy Walston, Robert Y. Loo, Mehran Mehregany, and Jae Lee, "Surface-micromachined RF MEMS switches on GaAs substrates," International Journal of RF and Microwave CAE, Vol. 9, No. 4, July 1999, pp. 348-361.	
	4	Y. Wang, Z. Li, D. T. McCormick, and N. C. Tien, "A Low-voltage Lateral MEMS Switch with High RF Performance," Journal of MicroElectroMechanical Systems (JMEMS), Vol. 13, No. 6, December 2004, pp. 902-911.	
	5	Yao, J.J., "RF MEMS from a device perspective", Journal Micromechanics and Microengineering 10: R9-R38, 2000	
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Examiner Signature	5-and	n_	Date Considered	3/3//00
*EXAMINER: Initia	if reference considered, whe	ther or not citation is in conformance with MPEP 60	09 Draw line through c	tation if not in conformance and not

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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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